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AF

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Appandria, VA 22313-1450, on the date shown below.

Dated: March 29, 2005

nature:

Docket No.: 30205/39380

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Jong Goo Jung et al.

Application No.: 10/603,976

Filed: June 25, 2003

For: CMP SLURRY COMPOSITION FOR OXIDE

FILMS AND METHODS FOR FORMING METAL LINE CONTACT PLUGS USING THE

SAME

Confirmation No.: 3741

Art Unit: 2813

Examiner: Stephen W. Smoot

AMENDMENT AFTER FINAL ACTION (37. C.F.R. SECTION 1.116)

Do Not Enter

MS AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Q.W.S.

4-11-05

INTRODUCTORY COMMENTS

In response to the final office action dated January 6, 2005, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.